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CONFIRMATION NO. 2532

<b>SERIAL NUMBER</b> 10/573,017	<b>FILING or 371(c) DATE</b> 01/19/2007 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 4174	<b>ATTORNEY DOCKET NO.</b> Q83324		
<b>APPLICANTS</b> Kenji Yakushiji, Chiba, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP05/15308 08/17/2005 which claims benefit of 60/605,500 08/31/2004 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2004-240764 08/20/2004 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 02/15/2008						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/SHIZHI CHEN/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance <u>/sc/</u> Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 2	<b>TOTAL CLAIMS</b> 12	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES						
<b>TITLE</b> Method for Fabrication of Semiconductor Light-Emitting Device and the Device Fabricated by the Method						
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees			
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